

FORM PTO-1449 (Additional references) Page 1 of 1	Atty. Docket No.: H26341 D1 (1139.1124103)	Serial No.: 10/617,290
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	Applicant: Ralph H. Johnson et al.	
	Filing Date	Group Art:
	July 10, 2003	unknown



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Examiner Initial	Document No.	Date	Name	Filing Date If Appropriate
	6,064,683	05/16/2000	Johnson	

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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DATE CONSIDERED: 12/22/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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

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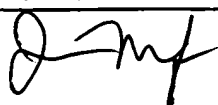
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

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

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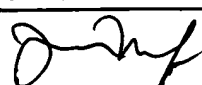
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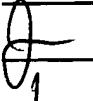

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	6,372,533 B2	04/16/2002	Jayaraman et al.			
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






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








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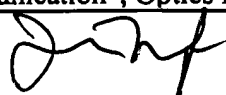
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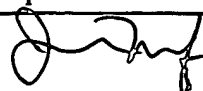
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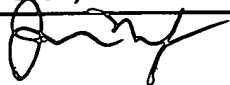
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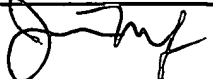
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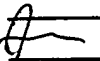

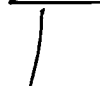




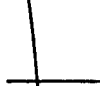


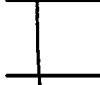


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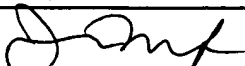
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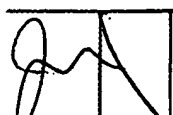
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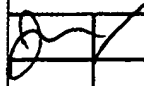
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	Applicant: Ralph Johnson et al.		
	Filing Date July 10, 2003	Group Art: unknown	

U.S. PATENT DOCUMENTS

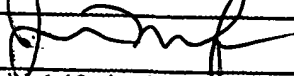
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